

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

Nobuaki HASHIMOTO

Group Art Unit: 2822

Application No.: 09/856,627

Examiner: I. Soward

Filed: May 24, 2001

Docket No.: 109609

For: INTERCONNECT SUBSTRATE,  
SEMICONDUCTOR DEVICE, METHODS OF  
FABRICATING, INSPECTING, AND MOUNTING  
THE SEMICONDUCTOR DEVICE, CIRCUIT  
BOARD, AND ELECTRONIC INSTRUMENT

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

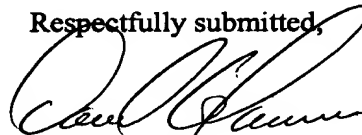
In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 149024 in the amount of ☒ \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,



James A. Oliff  
Registration No. 27,075

Daniel A. Tanner, III  
Registration No. 54,734

JAO:DAT/brc

Date: December 8, 2003

**OLIFF & BERRIDGE, PLC**  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461